

Electronic Patent Application Fee Transmittal

Application Number:	10779397			
Filing Date:	13-Feb-2004			
Title of Invention:	Substrate processing apparatus and substrate processing method			
First Named Inventor/Applicant Name:	Naoki Shindo			
Filer:	David Tai-Wei Yang/Deanna Fintz			
Attorney Docket Number:	199372003910			
Filed as Large Entity				
Utility under 35 USC 111(a) Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				
Extension - 2 months with \$0 paid	1252	1	490	490

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
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Total in USD (\$)				490